

**Search Notes**

Application/Control No.

10/554,263

Examiner

David E. Bochna

Applicant(s)/Patent under  
Reexamination

KIM, SUKYOON

Art Unit

3679

**SEARCHED**

Class	Subclass	Date	Examiner
285	307	1/7/2007	DB
	322		
	323		
	332.1		
	255		

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR